

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Kyoichi KINOSHITA; Takashi YOSHIDA; Tomohei SUGIYAMA; Hidehiro KUDO; and Eiji KONO

Serial No.: TBA

Group Art Unit: TBA

Filed: Herewith

Examiner: TBA

For: RADIATOR SYSTEM, RADIATING METHOD, THERMAL BUFFER,  
SEMICONDUCTOR MODULE, HEAT SPREADER AND SUBSTRATE

**INFORMATION DISCLOSURE STATEMENT**

**Mail Stop Patent Application**

Commissioner for Patents

PO Box 1450

Alexandria, Virginia 22313-1450

Sir:

Pursuant to Rule 56, applicant hereby calls the attention of the Patent Office to the references listed on the attached Form PTO 1449. Copy(ies) of these references ☒ are attached ☐ were filed in related application U.S. Serial No(s) \_\_\_\_\_, filed \_\_\_\_\_, respectively.

- ☐ This document is being filed within three (3) months of the filing date of the application
- ☐ Please charge the \$180 fee to Deposit Account No. 13-4500, Order No. \_\_\_\_\_.
- ☒ This document is being concurrently filed with the above-identified application
- ☐ This document is being concurrently filed with an Request for Continued Examination (RCE)
- ☐ This document is being filed prior to a first Office Action
- ☐ This document is accompanied by a Search Report/Communication cited in a corresponding PCT or foreign counterpart application.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required for this Information Disclosure Statement, or credit any overpayment to Deposit Account No. 13-4500, Order No. 5000-5108. A DUPLICATE COPY OF THIS SHEET IS ATTACHED.

Respectfully submitted,  
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Dated: July 7, 2003

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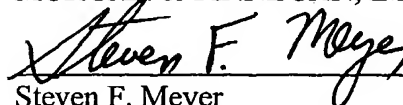
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<b>FORM PTO-1449</b>  <b>INFORMATION DISCLOSURE CITATION</b>	Attorney Docket: 5000-5108	Serial No.: TBA
	Applicant: Kyoichi KINOSHITA; Takashi YOSHIDA; Tomohei SUGIYAMA; Hidehiro KUDO; and Eiji KONO	
	Filing Date: Herewith	Group Art Unit: TBA

### U.S. PATENT DOCUMENTS

Examiner Initial	Patent Number	Publication Date	Name	Class	Sub-Class	Filing Date

### FOREIGN PATENT DOCUMENTS

Examiner Initial		Patent Number	Publication Date	Country	Class	Sub-Class	Translation
	1	63-20448	10 February 1988	JAPAN	H 01 L	23 / 36	Accompanied by its English Statement of Relevancy
	2	2000-77582	14 March 2000	JAPAN	H 01 L	23 / 373	Accompanied by its English Abstract
							<input type="checkbox"/> Yes <input type="checkbox"/> No
							<input type="checkbox"/> Yes <input type="checkbox"/> No
							<input type="checkbox"/> Yes <input type="checkbox"/> No

### OTHER DOCUMENTS (Including Author, Title, Date, etc.)

Examiner	Date Considered
<b>EXAMINER:</b> Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.	